Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	15	("4849070" "4001465" "4473747" "4744623" "4075493" "4752141" "6411759").pn.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON .	2006/09/29 18:03
S2	2	"20020003917"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 14:42
S 3	2	"20060115202"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 14:52
S4	16	(sensor near2 optic\$2) and ((substrate near2 silicon) same (silicon adj dioxide) same (optic\$2 near2 fiber))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 15:09
S5	4	("6546804" "4163953").pn.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 15:03
S6	16	("4773972" "5060526" "5559358" "5559358" "6324897" "5808210" "6031944" "6227055" "6246638"). pn.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 15:04
S7	20	(sensor near2 (optic\$2 or temperature or pressure)) and ((substrate near2 silicon) same (silicon adj dioxide) same (optic\$2 near2 fiber))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 15:16
S8	4	S7 not S4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 15:15

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S9	237	(sensor near2 (optic\$2 or temperature or pressure)) and ((substrate near2 silicon) same (optic\$2 near2 fiber))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 15:17
S10	58	S9 and (silicon adj dioxide)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 15:29
S11	38	S10 not S7	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 15:24
S12	179	S9 not (S7 or S10)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 15:29
S13	1733	385/12.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 15:29
S14	434	S13 and silicon	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON .	2006/09/29 15:30
S15	138	S13 and (silicon near2 (substrate or wafer or chip))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 15:49
S16	638	374/161.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 15:52

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S17	158	356/480.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 15:49
S18	. 634	S16 not (S7 or S9 or S17)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 16:34
S19	1681	S13 not (S7 or S9 or S16 or S17)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 16:34
S20	25	"ueno" and "kyocera" and "yuriko"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 17:56
S21	305	"nomura" and "yoshikazu" and "fujikura"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 17:57
S22		S21 and "385"/\$.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 17:59
S23	1709	385/39.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 17:59
S24	21998	(pressure adj sensor).ti.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 18:04

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S25	241	S24 and (optic\$2 near sensor)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 18:04
S26	33	S25 and (sensor adj system)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 18:07
S27	1371	(optic\$2 near sensor) and (channel with align\$4)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 18:08
S28	536	(optic\$2 near sensor) and (channel near2 align\$4)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR ,	ON	2006/09/29 18:08
S29	18	(optic\$2 near sensor) and ((channel near2 align\$4) with (optic\$2 near2 fiber))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/29 18:08
S30	9	("soi" adj wafer) with oxidi\$4 with ((silicon adj dioxide) or "sio2")	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/12/22 16:50